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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Kazuhide Hasebe, et al.

Serial No.: 10/552,262

Art Unit: Not Yet Assigned

Filed: October 5, 2005

Examiner: Not Yet Assigned

For: SILICON DIOXIDE FILM REMOVING METHOD AND
PROCESSING SYSTEM

EXAMINER'S STATUS INQUIRY

Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicant asks to be informed of the status of this patent application. Applicant filed the application on October 5, 2005, and has not received any paper from the PTO in connection with this case.

Respectfully submitted,

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